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Please type a plus sign (+) inside this box ™ Approved for use through 10/31/02. OMB 065 U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it displays a valid OMB control number. **Application Number** 10/618,155 TRANSMITTAL July 11, 2003 Filing Date **FORM First Inventor** Jaime Poris 4143 Confirmation No. 2813 **Group Art Unit** (to be used for all correspondence after initial filing) Erik J. Kielin **Examiner Name** Total Number Of Pages In This Submission **NAN068 US** 13 Attorney Docket No. **ENCLOSURES** (check all that apply) Fee Transmittal Form **Assignment Papers** After Allowance Communication to (1 page in duplicate) (for an Application) Fee Attached -- Credit Appeal Communication to Board of Drawing(s) Card Payment Form (1 pg) Appeals and Interferences Amendment / Reply (12 X Appeal Communication to Group Licensing-related Papers pages) (Appeal Notice, Brief, Reply Brief) After Final Petition **Proprietary Information** Petition to Convert to a Affidavits/declarations Status Letter **Provisional Application** Power of Attorney, Revocation of Other Enclosure(s) (please identify Previous Powers; And Statement **Extension of Time Request** Under 37 CFR 3.73(b) Terminal Disclaimer RETURN RECEIPT POSTCARD **Express Abandonment Request** Request for Refund Information Disclosure Statement CD, Number of CD(s)_ Certified Copy of Priority Document(s) Remarks This is a Response to Missing Parts/ Incomplete Application under 37 CFR 1.52 or 1.53 Copy of Notice To File Missing Parts (2 pages) SIGNATURE OF APPLICANT, ATTORNEY OR AGENT Firm Michael J. Halbert (Reg. No. 40,633) Silicon Valley Patent Group LLP Individual Name 2350 Mission College Boulevard, Suite 360 Santa Clara, California 95054 Signature

EXPRESS MAIL LABEL NO. EV 655 768 244 US .

Date

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors:

Jaime Poris

Assignee:

Nanometrics Incorporated

Title:

JUN 2 2 2005

Accurate Thickness Measurement of Thin Conductive Film

Serial No.:

10/618,155

Filing Date:

July 11, 2003

Examiner:

Erik J. Kielin

Group Art Unit:

2813

Docket No.:

NAN068 US

Confirmation No.:

4143

Santa Clara, California June 22, 2005

Mail Stop Amendment Commissioner For Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

This Response to Office Action is responsive to the April 7, 2005, Office Action, which has a statutorily shortened period for response that ends July 7, 2005. Please enter the following amendments before taking action on the merits of the above-referenced application.

SILICON VALLEY
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